IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Alan F. Jankowski et al Docket No.

IL-10991

Customer No: 24981

Serial No.

Art Unit

Filed

Examiner

For

Vapor-Deposited Porous Films for Energy

Conversion

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Alexandria, VA 22313-1450

Dear Sir:

Forwarded herewith is an Information Disclosure Statement, Form-1449, in the above-identified application. Copy of the cited reference is enclosed.

Respectfully submitted,

Ann M. Lee

Agent for Applicants Registration No. 47,741

Dated:

Enclosure:

As noted above

PTO/SB/08B (08-00)

Approved for use through 10/31/2002. OMB 0651-0031

U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

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		T. Tsai et al	Sputter deposition of cermet fuel electrodes for solid oxide			e J. vac. Sci, Lechnol. A 13 (3)								
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¹ Unique citation designation number. ² Applicant is to place a check mark here if English language Translation is attached. SEND TO: Commissioner for Patents, Washington, DC 20231